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H-mode pedestal versus X-point height (Towards FY11 JRT)

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Use X-point height as a tool to explore the effect of neutral penetration on the H-mode pedestal

- What leads to increase in n_e profile after LH or ELM and sets ultimate n_e width?
 - Neutral penetration or particle pinch?
 - Most neutral penetration past SOL is recycled neutrals from divertor plate
 - Vary distance between separatrix and outboard divertor plate with low neutral density
 - Low n₀ leads to wider gradients in n₀ near divertor
- NSTX: Achieve low recycling regime via lithium coatings
 - Pedestal and ELM stability influenced by recycling changes
 - Unique regime can be used to help decouple pinch vs neutral penetration effects





Goal: measure the pedestal pressure profile prior to type-I ELM and assess ELM cycle vs X-point height

- ELM cycle
 - Timing of T_e , n_e build-up to saturating pressure
 - Does neutral penetration impact n_e recovery?
 - Edge fluctuations: density fluctuations prior to ELM crash and flow shear prior and during ELM crash
- Inter-ELM profile analysis
 - Need frequent type-I ELMs to get profile composite
 - Does neutral penetration impact saturated n_e profile?
 - Aided by MPTS upgrade
- Shot development
 - Upgraded X-point height, outer strike-point controller
 - Could follow Ahmed's XP that establishes ELMy low- δ discharge

Experimental plan for 1/2 day XP

- Establish low-δ shape with large X-point height
 - Low- δ reference, with X-point height ramp after SOFT
 - X-point height and strike point control
 - Align outer strike point with tile probes

Intermediate X-point height (Ahmed's XP)

- Need well-spaced Type-1 ELMs
 - Modest lithium
 - Tricks: d_{rsep}, NBI power, fueling

Establish matched shape with small X-point height 4 – 6 shots

- Match elongation, aspect ratio and strike-point locations
- If time
 Repeat with reduced inter-shot lithium (or no lithium
- 6 10 shots

4-6 shots

4-6 shots

Diagnostic needs, planned analysis

- Required
 - Profiles: MPTS, CHERs, magnetics
 - ELMs: D_alpha, SXR diode array
- Desired
 - Edge modes / flows: GPI, reflectometer, BES, high-K
 - Recycling: 1D D_alpha CCD, filterscopes
 - Reconstructions: MSE
 - SOL currents: Shunt measurements
 - Additional profile information: Multi-color SXR, ERD
- Analysis
 - Osborne profile analysis tools
 - ELITE, PEST, TRANSP